Examiner-Initiated Interview Summary	Application No.	Applicant(s)
	10/766,035	ANDO ET AL.
	Examiner	Art Unit
	Jeffrey D. Lane	2828
All Participants: Status of Application:		
(1) <u>Jeffrey D. Lane</u> .	(3)	
(2) Fred Gibb.	(4)	
Date of Interview: 25 May 2006	Time:	
Type of Interview: ☐ Telephonic ☐ Video Conference ☐ Personal (Copy given to: ☐ Applicant ☐ Applicant's representative) Exhibit Shown or Demonstrated: ☐ Yes ☐ No If Yes, provide a brief description:		
Part I.		
Rejection(s) discussed:		
Claims discussed:	•	
1,3,5,6,7,13,14		
Prior art documents discussed:		
Part II.		
SUBSTANCE OF INTERVIEW DESCRIBING THE GENERAL NATURE OF WHAT WAS DISCUSSED: anticedent basis and possible typos. Change of "said active laser" to "said active layer" and "said semiconductor layer" to "said plural semiconductor layers"		
Part III.		
 ☑ It is not necessary for applicant to provide a separate record of the substance of the interview, since the interview directly resulted in the allowance of the application. The examiner will provide a written summary of the substance of the interview in the Notice of Allowability. ☑ It is not necessary for applicant to provide a separate record of the substance of the interview, since the interview did not result in resolution of all issues. A brief summary by the examiner appears in Part II above. 		
allmin Lane		
(Examiner SPE Signature) (Applicant	/Applicant's Representative Si	gnature – if appropriate)

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